

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Franz LAERMER
Serial No. : To Be Assigned
Filed : Herewith
For : DEVICE AND METHOD FOR PRODUCING CHLORINE
TRIFLUORIDE AND SYSTEM FOR ETCHING
SEMICONDUCTOR SUBSTRATES USING THIS DEVICE

Art Unit : To Be Assigned
Examiner : To Be Assigned

Mail Stop PCT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

**PRELIMINARY AMENDMENT AND
37 C.F.R. § 1.125 SUBSTITUTE SPECIFICATION STATEMENT**

SIR:

Please amend without prejudice the above-identified application before examination, as set forth below.

AMENDMENTS TO THE SPECIFICATION begin on page 2 of this paper.

AMENDMENTS TO THE CLAIMS are reflected in the listing of claims, which begins on page 3 of this paper.

REMARKS begin on page 5 of this paper.